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## \*BIBDATASHEET\*

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CONFIRMATION NO. 836

SERIAL NUMBER 10/087,855	FILING DATE 03/05/2002  RULE	CLASS 156	GROUP ART UNIT 1763	ATTORNEY DOCKET NO. SEC.884
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## APPLICANTS

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\*\* CONTINUING DATA \*\*\*\*\* *M**NONE*\*\* FOREIGN APPLICATIONS \*\*\*\*\* *M*

REPUBLIC OF KOREA 2001-15655 03/26/2001

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

\*\* 04/08/2002

Foreign Priority claimed

☒ yes ☐ no

35 USC 119 (a-d) conditions met

☒ yes ☐ no ☐ Met after Allowance

Verified and Acknowledged

Examiner's Signature *Robert C. ...*Initials *RC*

STATE OR

COUNTRY  
KOREA,  
REPUBLIC OF

SHEETS

DRAWING  
9

TOTAL

CLAIMS  
18

INDEPENDEN

CLAIMS  
2

## ADDRESS

20987  
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RESTON, VA  
20190

## TITLE

Method and apparatus for polishing a substrate while washing a polishing pad of the apparatus with at least one free-flowing vertical stream of liquid

FILING FEE

RECEIVED  
740

FEES: Authority has been given in Paper  
No. \_\_\_\_\_ to charge/credit DEPOSIT ACCOUNT  
No. \_\_\_\_\_ for following:

☐ All Fees☐ 1.16 Fees ( Filing )☐ 1.17 Fees ( Processing Ext. of time )☐ 1.18 Fees ( Issue )☐ Other \_\_\_\_\_☐ Credit